

AFT 2800

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Charles M. McKenna et al.
Serial No: 09/602,059
Confirmation No: 9493
Filed: June 23, 2000
For: ION IMPLANTER HAVING TWO-STAGE DECELERATION
BEAMLINE
Examiner: Mary A. El-Shammaa
Art Unit: 2881

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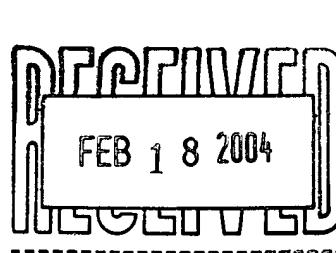
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Respectfully submitted,
Charles M. McKenna et al., Applicants

By:

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